

<b>APPLICANT'S ART CITATION</b> (Use several sheets if necessary)		Application    10/500,425		OFGS File No.    P/2107-253			
		Applicant        Achim WEBER					
		Filing Date      September 7, 2004		Group Art Unit    1645			
<b>U.S. PATENT DOCUMENTS</b> (not submitted for applications filed after 6/30/03)							
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub- class	Filing Date If Appropriate	
	US-						
	US-						
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<b>FOREIGN PATENT DOCUMENTS</b>							
	Document Number	Date MM-YYYY	Country	Class	Sub- class	Translation	
						Yes	No
<b>OTHER DOCUMENTS</b> (Including Author, Title, Date, Pertinent Pages, Etc.)							
		Y. Xia et al., "Soft Lithography", <i>Angew. Chem. Int. Ed.</i> , 37:550-575 (1998).					
Examiner		Date Considered					
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							